Application No. 10/731,089 Docket No. 740756-2676

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

For: MANUFACTURING METHOD FOR SEMICONDUCTOR DEVICE

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents 220 20<sup>th</sup> Street S. Customer Window, Mail Stop DD Crystal Plaza Two, Lobby, Room 1B03 Arlington, Virginia 22202

Sir:

Supplemental to the Information Disclosure Statement filed December 10, 2003 with the Abstract only, applicants hereby submit the full English translation of JP-2003-257950.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

Registration No. 35,483

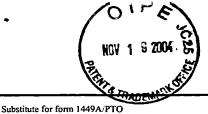
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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

Complete if Known			
Application Number 10/731,089			
Filing Date	December 10, 2003		
First Named Inventor Shinya SASAGAWA et			
Art Unit	1765		
Examiner Name			
Attorney Docket Number	740756-2676		

	U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.	U.S. Patent Document  Number - Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document  Kind Code <sup>3</sup> Country Code <sup>3</sup> Number <sup>4</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T*
-		JP 2003-257950	09/12/2003	Nobuyuki et al.		FULL
		OTHER PRIOR	ART – NON PATENT L	ITERATURE DOCUMENTS		
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.				

Examiner	Date	
Signature	Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

<sup>&</sup>lt;sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.